



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

MONA M. EISSA

Serial No. 10/621,879 (TI-28394.1)

Filed July 17, 2003

For: EFFECTIVE SOLUTION AND PROCESS TO WET-ETCH
METAL-ALLOY FILMS I SEMICONDUCTOR PROCESSING

Art Unit 1765

Examiner Kin-Chan Chen

Customer No. 23494

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

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10-17-05

Jay M. Cantor, Reg. No. 19.906

AMENDMENT UNDER 37 C.F.R. 1.116

In response to the Office action dated August 29, 2005, please amend the above-identified application as follows: